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To Commissioner of Patents and Trademarks	Total Pages Sent: 3 (including cover sheet)
Facsimile Number: (703) 872-9306	Transmission Date: February 19, 2004

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Tews, *et al.* Docket No.: 00P9031US
Serial No: 09/714,356 Art Unit: 2813
Date Filed: November 16, 2000
Title: Nitrogen Implantation Using a Shadow Effect to Control Gate Oxide
Thickness in DRAM Semiconductor

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Respectfully submitted,


Julie Russell
Legal Assistant

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